

Docket No.: 0051-0217P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Tomoyuki KOJIMA et al.

Application No.: 10/758,012

Confirmation No.: 5749

Filed: January 16, 2004

Art Unit: 3753

For: VACUUM SUCTION SYSTEM AND  
METHOD OF CONTROLLING THE SAME

Examiner: W. M. MCCALISTER

**AMENDMENT UNDER 37 C.F.R.1.116**

**MS AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**November 24, 2010**

Sir:

In response to the Office Action mailed August 27, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

This Paper includes

**Amendments to the Claims, and  
Remarks.**